IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Visco et al.

Attorney Docket No.:

LBNLP008D1/CIB-1406

Application No.: Not yet assigned

Examiner: Not yet assigned

Filed: November 26, 2003

Group: Not yet assigned

Title: METHOD OF MAKING A LAYERED COMPOSITE ELECTRODE/ELECTROLYTE

INFORMATION DISCLOSURE STATEMENT 37 CFR §§1.56 AND 1.97(b)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

The references listed in the attached PTO Form 1449 may be material to examination of the above-identified patent application. Applicants submit the list of these references in compliance with their duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. The Examiner is requested to make these references of official record in this application. The above-identified application is a divisional of prior application U.S. Patent Application No. 09/626,022. This prior application is being relied upon for an earlier filing date under 35 U.S.C. § 120. Because the listed references were either cited by the PTO, or submitted to the PTO in the prior application, under 37 CFR § 1.98(d) Applicants submit that copies need not be provided.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

This Information Disclosure Statement is: (i) filed within three (3) months of the filing date of the above-referenced application, (ii) believed to be filed before the mailing date of a first Office Action on the merits, or (iii) believed to be filed before the mailing of a first Office Action after the filing of a Request for Continued Examination under §1.114. Accordingly, it is believed that no fees are due in connection with the filing of this Information Disclosure Statement. However, if it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 500388 (Order No. LBNLP008D1).

Respectfully submitted,

BEYER WEAVER & THOMAS, LLP

Registration No. 39,489

P.O. Box 778 Berkeley, CA 94704-0778

Form 1449 (Modified)	Atty Docket No. LBNLP008D1/CIB-1406	Application No.: Not yet assigned
Information Disclosure Statement By Applicant	Applicant: Visco et al.	
Statement by Applicant	Filing Date	Group
(Use Several Sheets if Necessary)	November 26, 2003	Not yet assigned

U.S. Patent Documents

Examiner						Sub-	Filing
Initial	No.	Patent No.	Date	Patentee	Class	class	Date
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	A2	5,366,770	11.22.94	Wang			
	A3	5,670,270	09.23.97	Wallin			
	A4	5,932,368	08.03.99	Batawi, et al.			
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	A9	5,938,822	08.17.99	Chen et al.			
	A10	4,720,335	01.1998	Fukushima et al.			
	A11	6,017,647	01.2000	Wallin	1		
	A12	5,306,411	04.1994	Mazanec et al.			-

Foreign Patent or Published Foreign Patent Application

Examiner		Document	Publication	Country or		Sub-	Trans	lation
Initial	No.	No.	Date	Patent Office	Class	class	Yes	No
	B1	GB 1 383 343 A	12.02.74	Great Britain			X	
	B2	WO 97 00734 A	09.01.97	PCT			X	
	В3	JP-7-6768-A	01.1995	Japan		1		
	B4	JP-56-2549-A	01.1981	Japan	- 			<u> </u>

Other Documents

No.	Author, Title, Date, Place (e.g. Journal) of Publication			
C1	Christiansen, "Solid Oxide Fuel Cell", August 9, 2001, U.S. Patent Application			
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C2	Seabaugh, et al., "Low-Cost Fabrication Processes for Solid Oxide Fuel Cells,			
	NexTech exhibited at the Fuel Cells 2000 Conference in Portland October 30, 2000 –			
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C3	Fujii, K., et al., "Manufacturing and Charaterization of Metallic System Support Tube			
	for Solid Oxide Fuel Cells", Bullentin of the Electrotechnical Laboratory, Vol. 62,			
	No.1-2, 1998, pp. 1319			
C4	Momma, et al., "High Potential Performance of Tubular Type SOFC Using Metallic			
	System Components", Electrotechnical Laboratory, Electrochemical Proceedings			
	Volume 97-40, June 1997, pp. 310-321.			
	Date Considered			
	C1 C2			

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub- class	Filing Date
			<u> </u>				

Foreign Patent or Published Foreign Patent Application

Examiner		Document	Publication	Country or		Sub-	Trans	lation
Initial	No.	No.	Date	Patent Office	Class	class	Yes	No
	<u> </u>					1	+	1.0

Other Documents

		Other Documents
Examiner		
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	C5	Schiller, G., et al., "Development of Metallic Substrate Supported Thin-Film SOFC
		by Applying Plasma Spray Techniques", Electrochemical Society Proceedings Vol.
		99-19, October 1999, pp. 892-903.
	C6	Okua, T., et al., "Improvement in Power Stability and Durability Demonstration on
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		pp. 1-9.
	C7	Schiller, G., et al., "Development of Plasma Sprayed Components for a New SOFC
		Designs", Electrochemical Proceedings Vol. 97-40, October 1999, pp. 634-645.
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		Spraying", 1998, pp. 515-518.
	C9	Takenoiri, et al., "Development of Metallic Substrate Supported Planar SOFC at Fuji
		Electric", Fuel Cell Seminar Abstracts, November 1998, pp. 84-87.
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		Deposition Coatings on Ni-Base Superalloys", Department of Materials Science and
		Engineering, Vol. 984-92, 1994, pp. 984-992.
	C11	Wallin, et al., "Cofired Solid Oxide Fuel Cells for Operation at 800°C",1997,Abstract
	C12	
		pages 1-9.
	C13	Yao, et al, "Improved preparation procedure and properties for a multiplayer
		piezoelectric thick-film actuator", Sensors and Actuators A 71, Received 9 December
		1997; received in revised form 27 April 1998; accepted 1 May 1998, pp. 139-143.
	C14	Okuo, et al., "Development of Metallic Substrate Tubular SOFC", Electrotechnical
		Laboratory, October 1994, pp. 908-919.
	C15	Derwent abstract for JP-56-2549-A (1/1981).
Examiner		Date Considered
D	1	

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